

Notice of References Cited	Application/Control No. 10/823,836		Applicant(s)/Patent Under Reexamination RAVI, KRAMADHATI V.	
	Examiner Patricia A. George		Art Unit 1765	Page 1 of 2

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,993,916	11-1999	Zhao et al.	427/535
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*	V	Sokolowska; The structure and mechanical properties of carbon layers formed by crystallization from pulse plasma; Journal of material Science 21 (1986) 763-767)
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*	X	Ristein; Elsevier Science S.A.; 2000; Diamond and Related Materials 9 1129-1137; Electronic properties of diamond surfaces - blessing or curse for devices?

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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